

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: de Sandro, et al.

Serial No: 09/960559

Filed: 9/21/2001

For:

METHOD AND APPARATUS FOR
REDUCING STRESS BETWEEN
DEPOSITIONS WITHIN A
SUBSTRATE TUBE

Examiner: TBD

Group Art Unit: 1731

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.56, 1.97 – 1.98Asst. Commissioner of Patents and Trademarks
Washington, DC 20231

Dear Sir:

The Examiner's attention is hereby directed to the following reference(s) listed on the attached Form PTO-1449 for consideration in connection with the examination of the above-identified patent application. One copy of the reference(s) is enclosed.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the enclosed documents constitute "prior art." If it should be determined that any of the submitted documents do not constitute "prior art" under United States law, applicant(s) reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicant(s) further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the enclosed references, should one or more of the references be applied against the claims of the present application.

Respectfully submitted,

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Asst. Commissioner of Patents and Trademarks, Washington, D.C. 20231 on 12-31-02

Date of Deposit

Randall S. Wayland
Name of applicant, assignee, or
Registered Representative

12-31-02
Date of Signature

LIST OF PATENTS AND
PUBLICATIONS
FOR APPLICANT'S INFORMATION
DISCLOSURE STATEMENT

JAN 06 2003
SC1
TRADEMARK OFFICE

SP01-276

09/960559

APPLICANT de Sandro, et al.

FILING DATE 9/21/2001

GROUP: 1731

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
	AA	5,242,476	9/7/93	Bartel et al.	65	3.11	
	AB	6,116,055	9/12/00	Ishikawa et al.	65	399	
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

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TC 1700

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

AR	
AS	
AT	
AU	
AV	
AW	

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.